TRAN	NSMITTA	Docket No. 16782											
In Re Application Of: Yoshihisa Matsubara, et al.													
Application No.		Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.							
10/608,647		June 27, 2003	Roy Karl Potter	23389	2822	8331							
THE: OFMICONDUCTOR APPARATUS OF WHICH RELIABILITY OF INTERCONNECTIONS IS IMPROVED  AND MANUFACTURING METHOD OF THE SAME  2 6 204 5													
Address to:  Commissioner for Patents  P.O. Box 1450  Alexandria, VA 22313-1450													
1.   The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.													
2. 🗷	37 CFR 1.97(c)  The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:												
	★ the section 1.2. The section	statement specified i	n 37 CFR 1.97(e);										
			OR										
	□ tḥe f	ee set forth in 37 CF	FR 1.17(p).										

### TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. 16782 (Under 37 CFR 1.97(b) or 1.97(c)) In Re Application: Yoshihisa Matsubara, et al. Customer No. Group Art Unit Confirmation No. Examiner Filing Date Application No. 8331 **Roy Karl Potter** 2822 10/608,647 June 27, 2003 SEMICONDUCTOR APPARATUS OF WHICH RELIABILITY OF INTERCONNECTIONS IS NUFACTURING METHOD OF THE SAME **Payment of Fee** (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) ☐ A check in the amount of is attached. The Director is hereby authorized to charge and credit Deposit Account No. 19-1013/SSMP as described below. Charge the amount of Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile\* Certificate of Mailing by First Class Mail ertify that this document and authorization to charge deposit I certify that this document and fee is being deposited on account is being facsimile transmitted to the United States Aug. 24, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Patent and Aredemark Office (Fax. No. Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. (Date) USCI Signature Signature Aasheesh V. Shravah Typed or Printed Name of Person Signing Certificat Typed or Printed Name \*This certificate may only be used if paying by deposit account. Dated: August 24, 2004 Aasheesh V. Shravah Registration No. 54,445 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza Garden City, NY 11530 (516) 742-4343 AVS:jam

CC:

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshihisa Matsubara, et al. **Examiner: Roy Karl Potter** 

Serial No.:

10/608,647

Art Unit:

2822

Filed:

June 27, 2003

Docket:

16782

For:

SEMICONDUCTOR APPARATUS OF

Dated:

August 24, 2004

WHICH RELIABILITY OF

INTERCONNECTIONS IS IMPROVED AND MANUFACTURING METHOD OF THE SAME

Conf. No.:

8331

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 23313-1450

#### INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

- 1. Japanese Laid-Open Patent Application No. 6-177128, dated June 24, 1994;
- 2. Japanese Laid-Open Patent Application No. 6-97164, dated April 8, 1994;

# **CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 24, 2004.

Dated: August 24, 2004

Aasheesh V. Shravah

- 3. Japanese Laid-Open Patent Application No. 2002-75995, dated March 15, 2002; and
- 4. Japanese Laid-Open Patent Application No. 11-102909, dated April 13, 1999.

The references were cited in an Office Action dated August 3, 2004 received from the Japanese Patent Office. Applicants are submitting copies of the above-cited references, together with an English translation of the Examiner's comments regarding the references from the Official Action. The relevance of the references is described in the Official Action.

In compliance with the requirements of 37 C.F.R. §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 37 C.F.R. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

The undersigned attorney hereby states that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent

office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

Aasheesh V. Shravah

Reg.No. 54,445

Scully, Scott, Murphy & Presser 400 Garden City Plaza Garden City, New York 11530 (516) 742-4343

AVS:jam

AUG 2 6 2004 2 U.S. PATENT					Docket Number (Optiona 16782	Application Number 10/608,647				
					Applicant(s) Yoshihisa Matsubara, et al.					
					Filing Date June 27,	Group Art Unit 2822				
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*EXAMINER INITIAL	ref	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
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			FOREIG!	N PATI	ENT DOCUMENTS	<u> </u>	<u> </u>			
								TRANSI	LATION	
	REF	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	YES	NO	
		6-177128	6/24/1994	Japa	in					
		6-97164	4/8/1994	Japa	ın					
		2002-75995	3/15/2002	Japa						
		11-102909	4/13/1999	Japa	ın			-		
		OTHER DOCI	UMENTS (Inc.	Juding ,	Author, Title, Date, I	Dortinont Pages	Etc.)	<u></u>		
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EXAMINER					DATE CONSIDERED					
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Form PTO-A820 U.S. DEPARTMENT OF COMMERCE (also form PTO-1449) P09A/REV04

Patent and Trademark Office\*